



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: the Application of

Kiyoshi UCHIKAWA

Group Art Unit: 2882

Application No.: 10/588,730

Examiner: D. PERSAUD

Filed: October 18, 2007

Docket No.: 129041

For: EXPOSURE METHOD AND APPARATUS, AND DEVICE PRODUCTION METHOD

AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 22, 2011 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, and upon entry of the attached Request for Continued Examination, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.